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**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:  
Thomas Sonderman, et al

Serial No.: 09/751,083

Filed: December 29, 2000

For: METHOD AND APPARATUS FOR  
CONTROLLING WAFER THICKNESS  
UNIFORMITY IN A MULTI-ZONE  
VERTICAL FURNACE

Examiner: R. FULLER

Group Art Unit: 2851

Att'y Docket: 2000.044400

**RESPONSE TO OFFICE ACTION DATED MARCH 26, 2004**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Va. 22313-1450

CERTIFICATE OF TRANSMISSION 37 C.F.R. 1.6D	
I hereby certify that this correspondence is being transmitted by facsimile to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 at 1-703-872-9306 on the date below:	
9.23.04 Date	Kathy Damer Signature

Sir:

This paper is submitted in response to the Office Action dated March 26, 2004, for which the six-month date for response is Monday, September 27, 2004. Applicants hereby petition for a three-month extension of time to reply.

It is believed that a fee of \$950.00 is due for the extension of time; the Commissioner is hereby authorized to deduct the extension fees from Williams, Morgan & Amerson's P.C. Deposit Account No. 50-0786/2000.044400. Should additional fees under 37 C.F.R. §§ 1.16 to 1.21 be required for any reason, the Commissioner is authorized to deduct said fees from Williams, Morgan & Amerson's P.C. Deposit Account No. 50-0786/2000.044400.

Reconsideration of the application is respectfully requested.

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